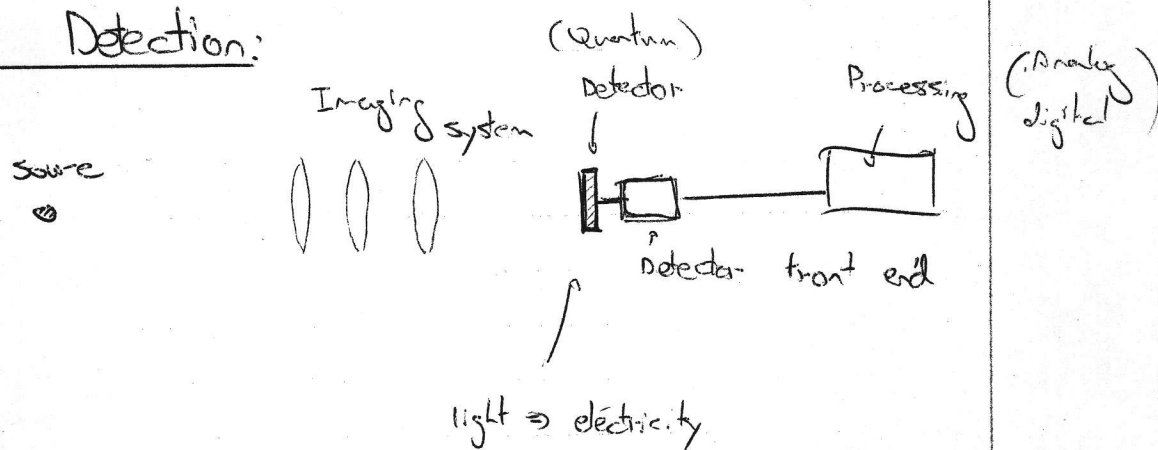


Optical Detection:



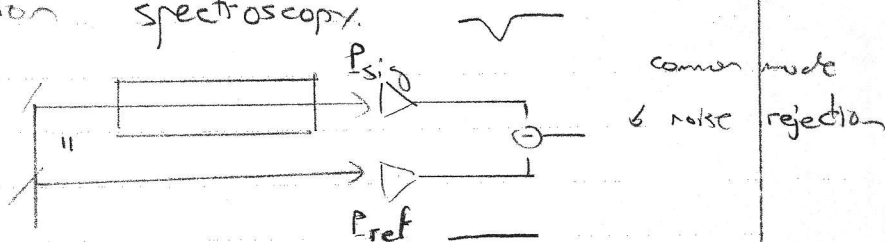
at the optical part.
what you screw up here, cannot be
retrieved at the electronics side.

i.e. the measurement minimum SNR is determined by
the optical side. can only be worsened by electronics

⇒ Photon budget:

How many photo-electrons will I get in a certain
integration time?

example: Absorption spectroscopy.



$$N_{sig} = \left[\frac{P_{sig}}{h\nu} \right] t_{meas} = \frac{1}{B} \left[\frac{P_{sig}}{h\nu} \right] \quad B = \frac{1}{t_{meas}}$$

$$N_e = \underset{\substack{\uparrow \\ \text{quantum} \\ \text{eff.}}}{\eta} (N_{ref} - N_{sig}) = \frac{\eta}{B} \left[\frac{P_{ref} - P_{sig}}{h\nu} \right]$$

su

$$\text{STD}(N_e) = \sqrt{2(N_{\text{ref}} + N_{\text{sig}})} = \sqrt{\frac{2}{B} \frac{P_{\text{ref}} + P_{\text{sig}}}{h\nu}}$$

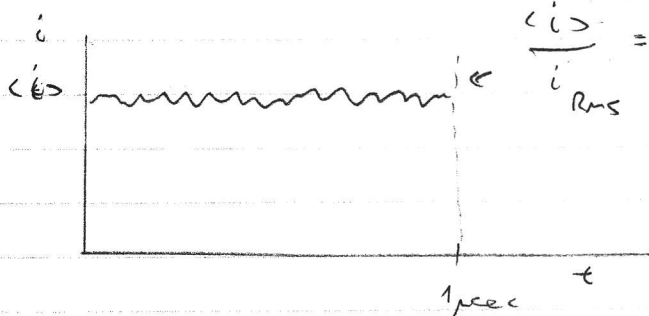
$$\Rightarrow \text{photocurrent SNR} = \sqrt{\frac{2}{B h \nu}} \frac{P_{\text{ref}} - P_{\text{sig}}}{\sqrt{P_{\text{ref}} + P_{\text{sig}}}}$$

Say we have a 1% absorption out of

100 μW beam, $B = 1 \text{ MHz}$

$$\lambda = 1 \mu\text{m} \Rightarrow \omega = 2\pi \times 2 \times 10^{14} \text{ Hz}$$

$$\sqrt{\frac{0.4}{10^6 \times 6 \times 10^{-34} \times 2 \times 10^{14}}} \frac{10^{-6}}{\sqrt{2 \times 10^{-4}}} = \frac{10^9}{\sqrt{60}} 10^{-4} \approx 10^4$$



$$\langle i \rangle = \frac{1}{t_0} \int_0^{t_0} i(t) dt$$

$$\frac{\langle i \rangle}{i_{\text{RMS}}} = \frac{\langle i \rangle}{(\langle i^2 \rangle - \langle i \rangle^2)^{1/2}}$$

$$\langle i^2 \rangle = \frac{1}{t_0} \int_0^{t_0} i^2(t) dt$$

SNR improves as $\sqrt{P}$; $\frac{1}{\sqrt{B}}$; $\sqrt{t}$

more
photons

more integration
time

high quantum
eff.

to normalize out $\frac{1}{\sqrt{B}}$ the above result can be stated

as

$$\text{SNR} = 10^7 / \sqrt{B t}$$

why $\frac{1}{\sqrt{B t}}$

noise would average better as $\frac{1}{\sqrt{t}}$ increases

noise power $i_{\text{RMS}}^2 R_L$ is white, noise energy
linear with B .

SS

SNR is usually given in terms of

$$\left(\frac{\text{signal power}}{\text{noise power}} \right)$$

in photo-detection $P_{\text{opt}} \propto i_{\text{elect.}}$ $P_{\text{elect.}} = (i_{\text{elect.}})^2 R_L$

$$P_{\text{opt SNR}} \propto \frac{1}{\sqrt{B}}$$

$$P_{\text{elect. SNR}} \propto \frac{1}{B}$$

very different

I believe that thinking in terms of photo-electrons rather than photons in optical measurement is healthier

1. η appears.

additional

2. Easier to compare to other noises: Johnson etc.

3. Quantum optics - more correct ^{esp.} for a coherent state

the 'is really noisy' - pure state. Noise in the outcome of

a Fock basis meas.

$$i_{\text{nsot}} = e \sqrt{2 \eta N_{\text{photo/sec}}}$$

$$= \sqrt{2 e i_{\text{sig}}}$$

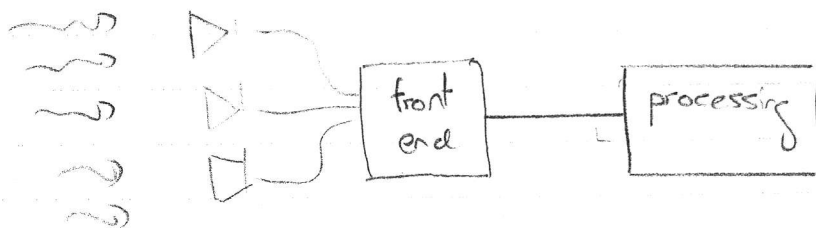
shot noise dominates when $V_{\text{sig}} > 50 \text{ mV}$

$$P_{\text{nsot}} = i_{\text{nsot}}^2 R_L = 2 e i_{\text{sig}} R_L = 4 K T \Rightarrow V_{\text{sig}} = \frac{2 K T}{e} = 50 \text{ mV}$$

P_{sensor} (thermal noise) in a resistor

$\approx 300 \text{ K}$

.56



photon Budget: Max SNR determined here.

Photon statistics: statistics of uncorrelated events with average occurrence λ per unit time.

$$P(N) = \frac{\lambda^N}{N!} e^{-\lambda}$$

↑
events / unit time

for large λ looks Gaussian, with width = $\sqrt{\text{average}}$

$\Rightarrow$ called Gaussian noise.

PSD - white. $I_d = 2 \frac{P}{h\nu} e$

of electrons $I_d T \equiv \frac{I_d}{2B}$

std of # electrons $= \sqrt{\frac{I_d}{2B} e}$

convert back to current i.e. $\times \frac{e}{T} \Rightarrow \text{std}(i_d) = 2Be \sqrt{\frac{I_d}{2Be}} = \sqrt{2e I_d B}$

comparing to Johnson - (Nyquist) noise.

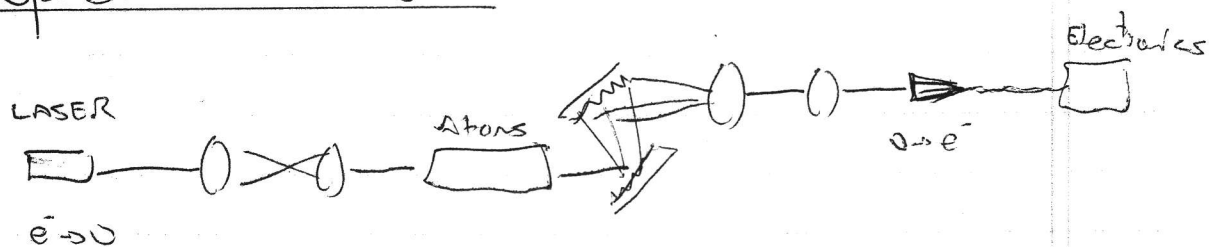
$$i_n = \sqrt{\frac{4k_B T B}{R}}$$

we get

$$I_n R = \frac{2k_B T}{e} = 51 \text{ mV}$$

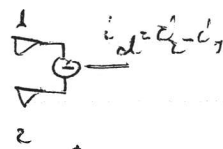
when the two contributions are equal!

Optical Detection



- what you screw up at the optical part
cannot be retrieved at the electronics side.
- ⇒ work on effort,
 - ⇒ All sensitive operations ⇒ perform at detector.

e.g. diff detection



bobbe interference, Johnson etc.

Detector figures of merit:

two types / Bolometers $\leftarrow$ High power:
/ Quantum detectors $\leftarrow$ i.e. photo-electric
photon $\leftrightarrow$ electron

- Aside: Superconducting transition edge bolometers
are the best (number resolving) single photon detectors.

$$\eta > 0.9.$$

- Here we discuss Q-det. / $\sigma(\text{CL}) = \sqrt{2 R E_d B}$
 $I_d R = \frac{V_{th}^2}{R} \Rightarrow 2 e I_d R = 4 k_B T \Rightarrow I_d R = \frac{2 k_B T}{e} = 51 \text{ mV}$

QE - Ratio of charge carriers to incident photons,

Responsivity $R [A/W]$

$$R = \frac{M \cdot \eta e}{h \nu}$$

detector multiplication gain (PP's $\rightarrow 1$ i.e. photo- 10^4)

$M = 1$ (photo-diodes) $R \sim 1 \text{ A/W}$ in IR

$\sim 0.3 \text{ A/W}$ in violet.

notice that for $\eta \neq \eta(\lambda)$ R is linear in λ

NEP Given some intrinsic noise mechanism
(independent of optical power).

NEP is the optical power req. for an SNR=1

- Intrinsic noise is not necessarily flat $\rightarrow$ NEP would depend
on how fast light is modulated.

NEP (cont.)

Quoted close to d.c. where roughly flat

in units of $W/\sqrt{Hz}$ ← the more you average

the less optical power you need for $SNR=1$

Since often the intrinsic noise increases with detector

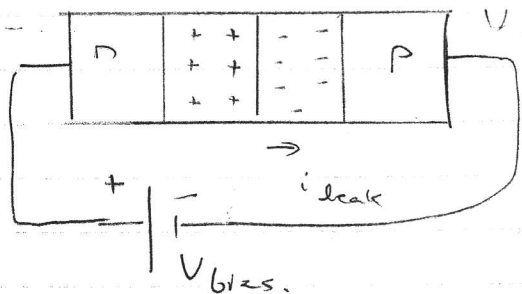
area size, sometimes quoted in units of $W/cm/\sqrt{Hz}$

Back here after PNs are discussed!!

compare between techs.

What is the intrinsic noise source?

example silicon photo-diode reversed biased!



$$R_{shunt} \sim \frac{V_{bias}}{i_{leak}}$$

(actually i_{leak} does NOT go to zero as $V_{bias} \rightarrow 0$)

two intrinsic noise contributions:

i_{leak} shot noise & R_{shunt} Johnson noise.

$$\sigma_N^2 = \frac{4k_B T B}{R_{shunt}} + 2e i_{leak} B$$

$\uparrow$
 1.38×10^{-23}
 1.6×10^{-19} coul.

Typical values: $i_{\text{leak}} \approx 100 \text{ pA}$ @ 10 V reverse bias.

$$\Rightarrow R_{\text{shunt}} = 10 \text{ G}\Omega$$

Johnson is $\approx 30 \times$ smaller compared to shot noise

$$i_{\text{shot noise/rms}} = 6 \text{ fA}/\sqrt{\text{Hz}} \approx \sqrt{3.2 \times 10^{-12} \cdot 10} \text{ A}/\sqrt{\text{Hz}}$$

$$\text{NEP} = \frac{i_{\text{shot noise/rms}}}{\sqrt{B}} \left[\frac{h\nu}{2e} \right] \approx 10 \text{ fW}/\sqrt{\text{Hz}}$$

$\eta = 80\% \Rightarrow 9 \text{ a.u.}$

what R do you need in order to be shot noise limited over 1 MHz
CLN

Capacitance: for photo-diodes typ. few pF $\rightarrow$ few 10's pF
(to ground)

Important to determine bandwidth, simply measure

voltage across R_L (1 M Ω on scope)

$$B = \frac{1}{2\pi R C} \approx \frac{10^{11}}{2\pi \times 10^6} = 2 \times 10^4 \text{ Hz}$$

$\uparrow$
10 pF

$\uparrow$
not very fast

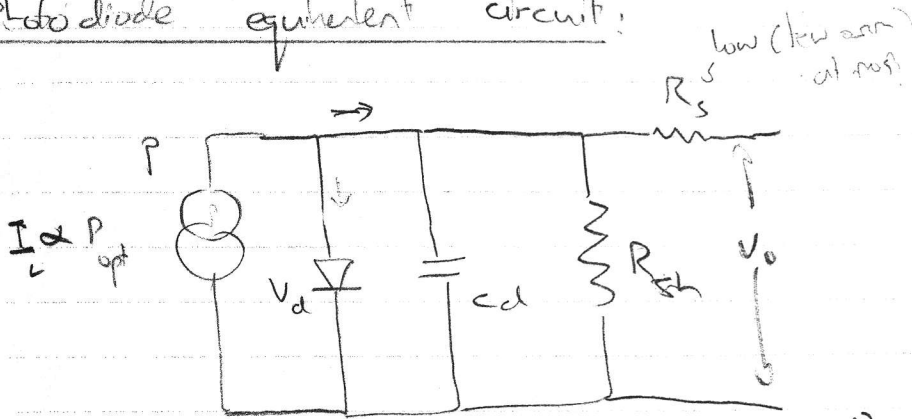
- can do better $\Rightarrow$ front ends.

- spectral response: photo diode, below band gap is IR
 τ_{ev} - absorption before depletion region
 - photon electron disintegration mismatch.

Si $\sim 200 - 1100 \text{ nm}$

- spatial uniformity: $\sim 10\%$ variation.

Photodiode equivalent circuit:



$$C_d = \frac{C_0}{\sqrt{1 + V_R/V_d}}$$

$$V_R \rightarrow 0$$

$$R_{sh} \rightarrow \infty$$

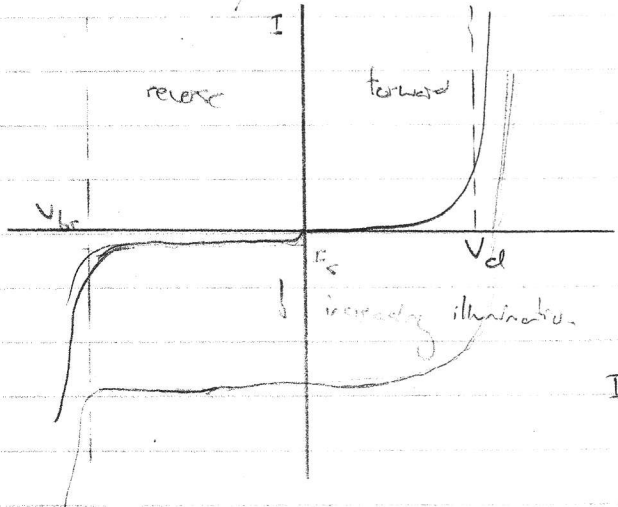
$$I_{pass} = I_{diff} + I_{diffusion}$$

holes are ~2.5 slower than electrons

until full depletion across

otherwise V_{ind} of reverse bias $\sim 0.6V$

Shockley diode eq: $I = I_s (e^{V_d/qV} - 1)$



$$I_s \propto e^{-\frac{E_g}{kT}}$$

$$I_{ph} = I_o - I_s$$

always works in Reverse bias mode:

↑ faster drift charge depth
→ more efficient

Except when detecting at Push non-linearity

very low light levels $\Rightarrow$ NEP $\uparrow \Rightarrow$ leakage current.

Photo diodes basics: $\uparrow$ cheap, linear, fast, small, wide area?

Example Si - 4 valence electrons, Band gap = 1.1 eV

- doped with a low concentration $10^{13} - 10^{18} / \text{cm}^3$

of:

- donor = 5 valence electron atom: arsenic, phosphorus

n-type, the extra electron can be easily thermal, excited to conduction band.

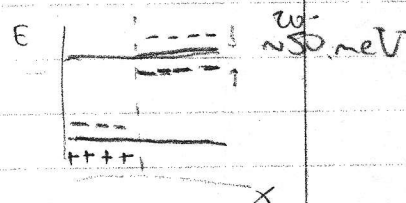
- acceptor = 3 valence electron atom: Boron

p-type, holes thereby formed in valence band.

Energy Distance of donor/acceptor from conduction/valence

band $\sim 20 - 50 \text{ meV}$, i.e. at 300K doped

Si is conducting.

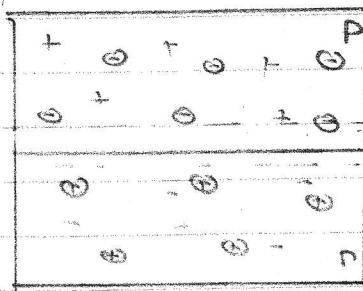


P-N junction

depletion region

carriers migrate and

recombine.



+ mobile

$\ominus$ fixed

- mobile

$\oplus$ fixed

donor/acceptor ions form charge density - in p-type

and + in n-type $\Rightarrow$ electric field across junction.

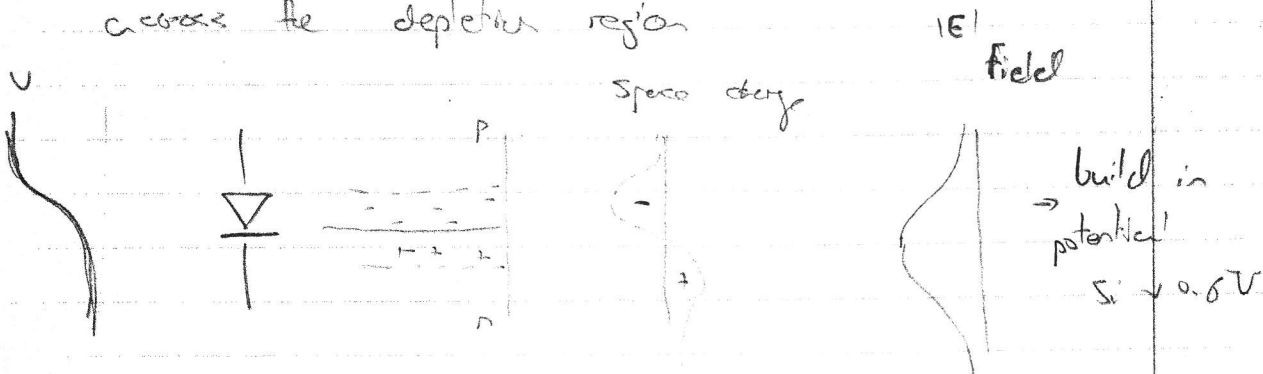
Apply - to n-type and + to p-type, charge carriers move into depletion region - diode conducting (after you overcome $\approx 0.6V$ potential barrier)
 $\Rightarrow$ Forward bias.

- Apply + to p-type and - to n-type, carriers move away from depletion region

$\Rightarrow$ Reverse biased

- Diode is not conducting and depletion region grows.

across the depletion region



a photon with $hw > 1.1 \text{ eV}$ i.e. $\lambda \leq 1.1 \mu\text{m}$

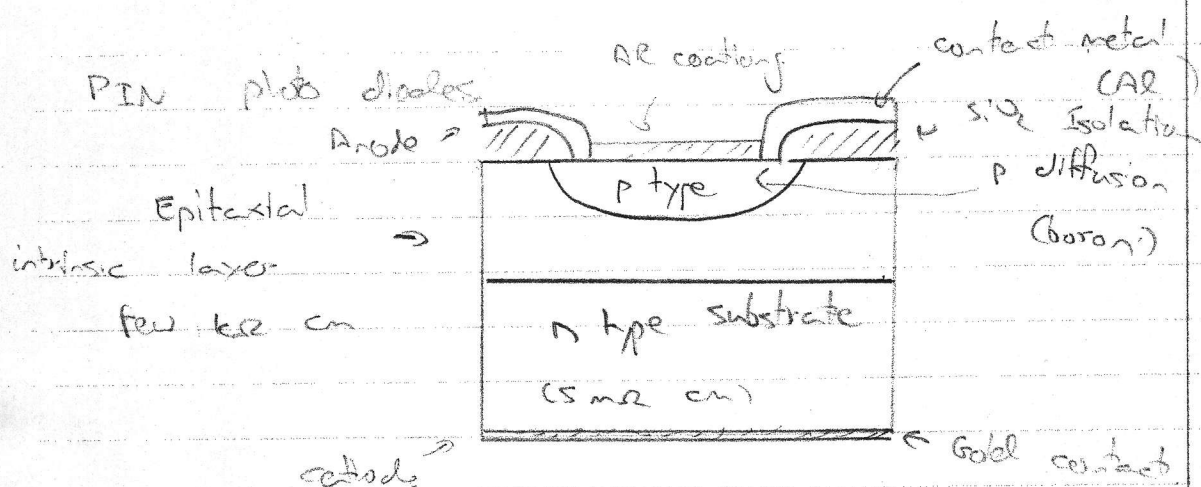
that is absorbed in depletion layer forms

electron-hole pair. Electric field separates the

two. If diode not connected, p-type (anode)

becomes positively charged, n-type (cathode) negatively charged.

If connected, current flows from anode to cathode.



Intrinsic layer: increases depletion area.
more efficient; higher photon bandwidth.
actually increases speed.
(large area with electric field)

responsivity: cut off in IR
decrease in UV

IR No absorption when $\lambda > \lambda_g = \frac{hc}{E_g} \approx \frac{1.24}{E(\text{eV})}$

for Si $\lambda_g \approx 1.1 \mu\text{m}$. peak sensitivity (Si) $\approx 0.9 \mu\text{m}$.

- content at cathode mirror to generate
2-pass through depletion region

UV - photons absorbed too soon, no large E
field to separate them.

UV enhanced - depletion region as close as
possible to surface.

other examples for detector materials:

	λ_g (nm)
C (diamond)	0.23
GaN	0.35
Si	1.1
InGaAs	1.7 - 2.6
Ge	1.88

- AR coating for Si $n=3.5$

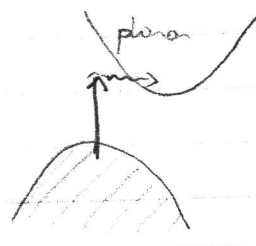
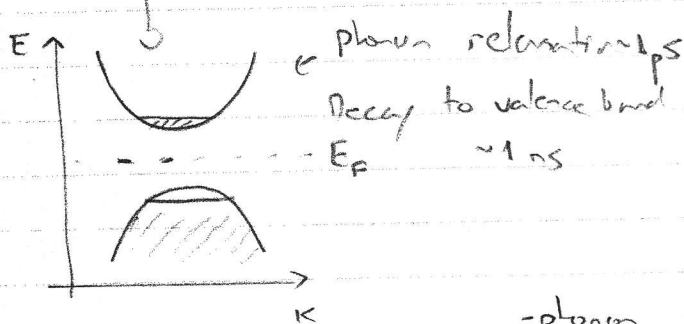
$\Rightarrow$ Fresnel reflector at normal incidence = 31% $= \left(\frac{n-1}{n+1}\right)^2$

$\Rightarrow$ w/o AR coating $\eta \sim 0.16$

w/ AR coating $\eta \sim 0.9$ possible

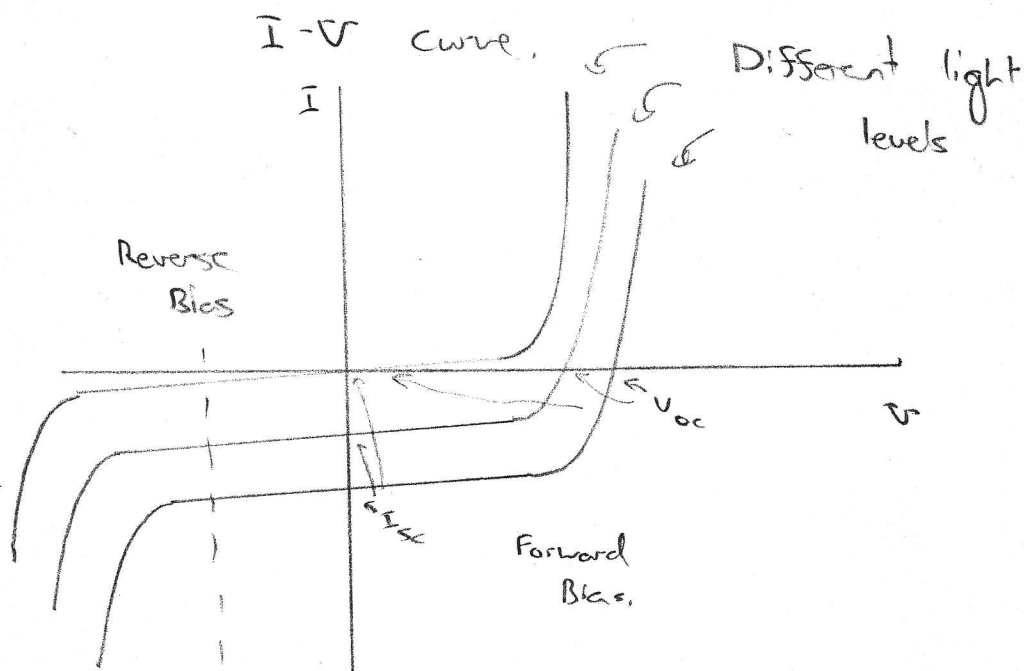
Non-direct band gap - e.g. Si

direct band gap - e.g. InGaAs



- photon relaxation $\Rightarrow$ very fast

- Direct band gap PDS more efficient e.g. InGaAs $\eta \sim 0.9$.63



← Always work in reverse bias mode

→ more efficient (larger depletion region)

→ Faster → C_d reduced by $\times 10$ or so

$$\tau_{pass} = \tau_{drift} + \tau_{diffusion}$$

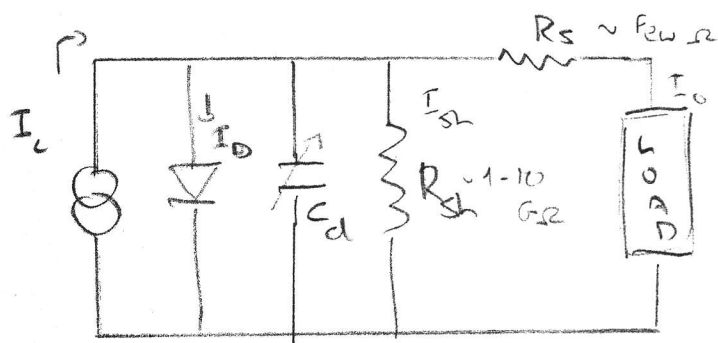
in depletion region outside depletion region

→ Push non-linearity to higher light levels due to stronger field.

Except when trying to low light levels

⇒ reduce I_{leak} and therefore I_{leak} shot noise

Yet again a trade-off between sensitivity and bandwidth.



$$C_d = \frac{C_0}{\sqrt{1 + \frac{V_{RB}}{V_d}}} \quad \leftarrow \text{until full depletion}$$

at d.c. (ie. no current through \$C_d\$)

$$I_o = I_L - I_D - I_{sh} = I_L - I_s \left(e^{\frac{eV_D}{kT}} - 1 \right) - I_{sh}$$

Open circuit: $I_o = 0$ ($R_{load} \gg R_{sh}$)

$$\Rightarrow V_{D_{oc}} = \frac{kT}{e} \ln \left[\frac{I_L - I_{sh}}{I_s} - 1 \right]$$

if no light $I_L = 0$ $I_{sh} = V_D / R_{sh}$

$$\Rightarrow V_{D_{oc}} = \frac{kT}{e} \ln \left[\frac{V_D}{I_s R_{sh}} \right] \Rightarrow V_D = 0.6 - 0.7 \text{ V}$$

when $I_L \gg I_{sh}$

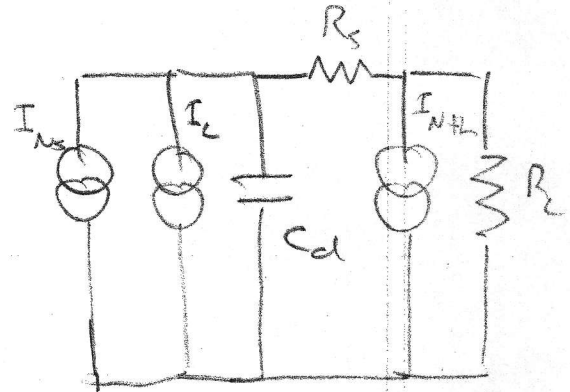
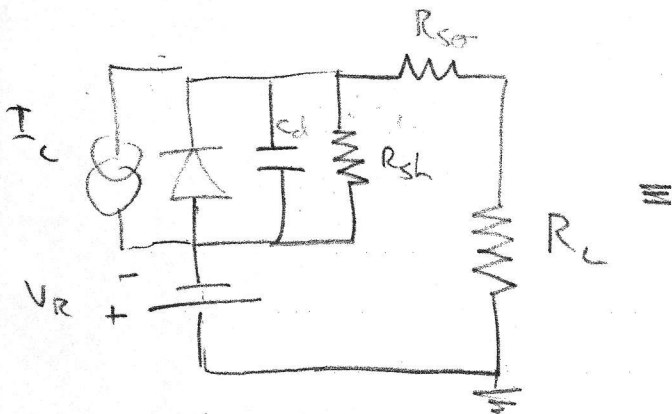
$$V_{D_{oc}} = \frac{kT}{e} \ln \left[\frac{I_L}{I_s} \right] \quad \leftarrow \text{non-linear in } P_{opt}$$

Short circuit: $V_D = 0$

$$I_{o_{sc}} = I_L - I_s \left(e^{\frac{e I_{sc} R_s}{kT}} - 1 \right) - \frac{I_{sc} R_s}{R_{sh}}$$

Front ends again:

The simplest front end - a resistor:



$$C_d = \frac{C_0}{\sqrt{1 + \frac{V_R}{V_d}}} \quad V_d \sim 0.6 \text{ V for Si}$$

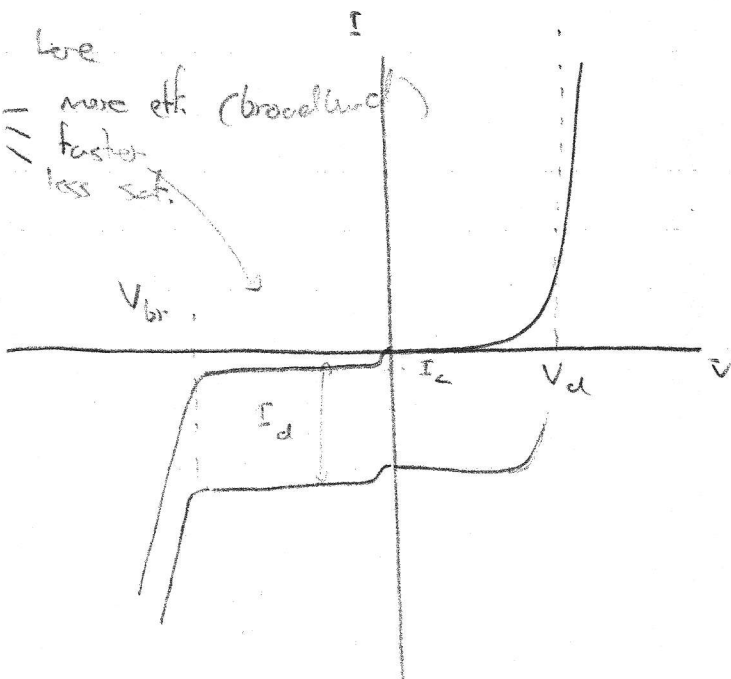
$$R_{sh} = \frac{V_R}{I_L} \sim 10 \text{ G}\Omega \quad I_L \sim 100 \text{ pA}$$

$t_{rr} \sim \text{few} \rightarrow 100 \text{ pF}$

work here
reverse bias = more eff. (broader band)
faster
less sat.

price of a small leakage current

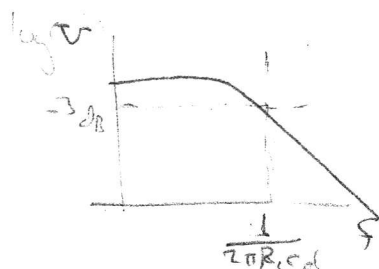
NEP



- Neglect I_i (absorb into I_d) and R_s (absorb into R_L)

$$Z^{-1} = i\omega C_d + \frac{1}{R_L} \Rightarrow Z = \frac{R_L}{1 + i\omega R_L C_d}$$

$$\Rightarrow V = \frac{I_d R_L}{1 + i\omega R_L C_d}$$



for responsivity = 0.5 A/V

$$P = 2 \mu W$$

$$I_d = 1 \mu A$$

$$\Rightarrow \text{for } 1V \Rightarrow R_L = 1 M\Omega$$

assuming $C_d = 100 \text{ pF}$ (large area diode) 10 pF

$$1 \mu A$$

$$f_{RC} \approx 1.6 \text{ kHz}$$

$$16 \text{ kHz}$$

$$160 \text{ kHz}$$

- SNR does not depend on f noise is $1/f$ suppressed as the signal

- Makes sense to lower R_L until

$$I_d R_L \approx 2 \times \text{SImer or so}$$

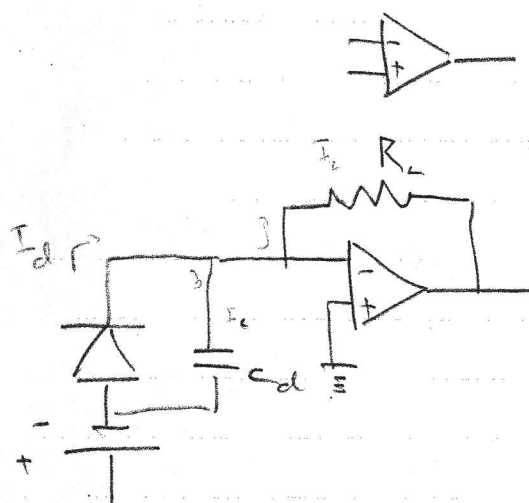
(Gain in terms of bandwidth as well as dynamic range.)

Trans impedance amplifiers:

Ideas: reduce voltage swing across C_d .

⇒ put C_d into virtual ground.

or Ideal op-Amp:



$$I_- = I_+ = 0$$

$$V_{out} = (V_+ - V_-)A$$

open-loop gain $A \rightarrow \infty$

- If $A \rightarrow \infty$ $(V_+ - V_-) = 0 \Rightarrow V_-$ is virtual ground

⇒ voltage across $C_d = 0$

$$I_d = I_c + I_-$$

$$I_c = -i\omega C_d V_-$$

$$I_c = \frac{V_{out} - V_-}{R_L}$$

$$V_{out} = -V_- A = I_c R_L + V_- = (I_d - I_c) R_L + V_- =$$

$$= (I_d + iV_- \omega C_d) R_L + V_- = \left(I_d + i \frac{V_{out}}{A} \omega C_d \right) R_L - \frac{V_{out}}{A}$$

$$\Rightarrow V_{out} = \frac{I_d R_c}{1 + \frac{1}{A} + i \frac{\omega R_c C_d}{A}} \approx \frac{I_d R_c}{1 + i \frac{\omega R_c C_d}{A}}$$

$C_d \Rightarrow C_d/A$
 or $R_c \Rightarrow R_c/A$

a miracle: response like: R_c
 corner like: R_c/A

For an ideal op-amp $A \rightarrow \infty \Rightarrow$ infinitely fast

Frequency Response:

Non-ideal op-amp: $A(f) = \frac{A_{dc}}{1 + i f/f_{amp}}$

- Amp adds more capacitance to ground.

$\Rightarrow$ effectively increases C_d by factor f^2

for large f $A(f) \sim -i \frac{f_{GBP}}{f}$

$f_{GBP} = A_{dc} \cdot f_{amp}$ = unity gain freq. ^{accurate} in op amp _{fab.}

$$\Rightarrow V_{out} = \frac{I_d R_c}{1 - \frac{2\pi f^2 R_c C_d}{f_{GBP}}} \equiv \frac{I_d R_c}{1 - \left(\frac{f}{f_{ti}}\right)^2}$$

where $f_{ti} = \sqrt{f_{RC} \cdot f_{GBP}}$ $f_{RC} = \frac{1}{2\pi R_c C_d}$

Stability:

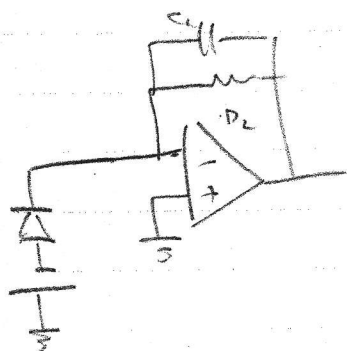
Notice that when $f = f_{ti}$

V_{out} diverges $\Rightarrow 180^\circ$ phase shift.

Negative feedback $\Rightarrow$ positive feedback.

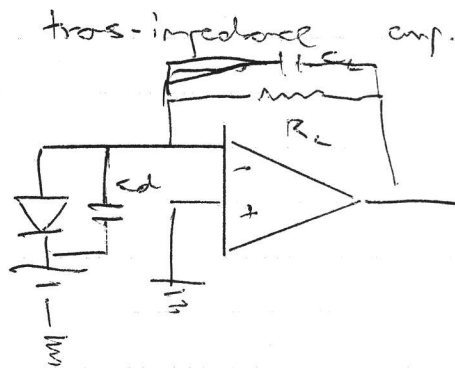
the circuit will now oscillate at the amplified freq.

to regain stability: add another capacitor C_L to roll-off the feedback gain at f_{ti} .



$$\text{where } \frac{1}{2\pi R_L C_L} \approx f_{ti}$$

last time:



$$f_{ti} = \sqrt{f_{RC} \cdot f_{GBP}}$$

$$f_{RC} = \frac{1}{2\pi R_c C_d}$$

$$f_{GBP} = A_{dc} \cdot f_c$$

choose C_d such that $\frac{1}{2\pi R_c C_d} \approx f_{ti}$ (stability)

Next lectures Feb 1st, Feb 8th Tuesdays

No lecture next monday. !!!

offset

Non-ideal: op-amp do have input currents

$$I_- \approx I_+ \quad (\text{Can be few \% level})$$

$$I_d = I_L + I_-$$

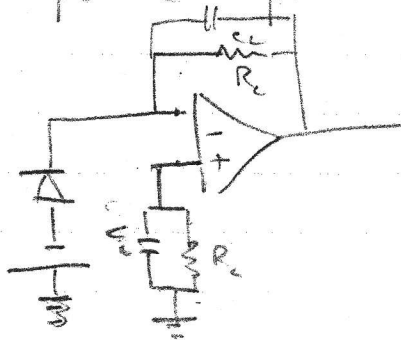
$$V_{out} = (I_D - I_-)R_L + V_- \Rightarrow V_- = V_{out} - (I_D - I_-)R_L$$

virtual GND
0
||

$$V_{out} = (I_D - I_-)R_L$$

$$\Rightarrow \underset{I_D=0}{=} -I_- R_L$$

to compensate: place R_c between $+$ and Gnd.



$$I_+ R_c$$

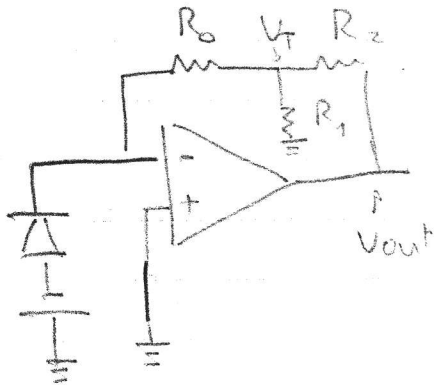
$$V_{out} = (I_D - I_-)R_L + V_-$$

same analysis:

$$\Rightarrow V_{out} = (I_+ - I_-)R_L + I_D R_c \sim \times 100 \text{ smaller}$$

This changes $V_R = V_{out} - I_+ R_c$ - reverse bias voltage.
usually not a problem unless want to work at $V_R \rightarrow 0$,
and large R_c (low light collection)

If want reduce line effect: Feedback Tee



$$I_1 = \frac{V_T}{R_1}$$

$$I_D = \frac{V_T}{R_0}$$

$$I_2 = I_D + I_1$$

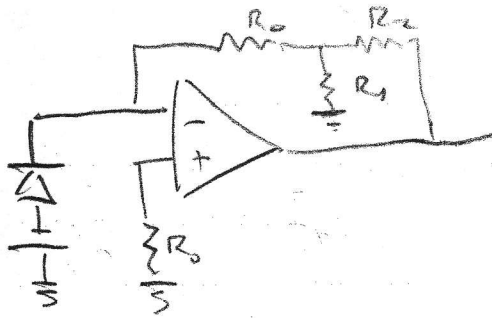
$$\Rightarrow V_{out} = V_T = I_2 R_2 = (I_D + I_1) R_2$$

$$V_{out} = I_D R_0 + (I_D + I_1) R_2 = I_D (R_0 + R_2) + \frac{V_T}{R_1} R_2 =$$

$$= I_D \left[R_0 \left(1 + \frac{R_2}{R_1} \right) + R_2 \right] \approx I_D R_0 \left(1 + \frac{R_2}{R_1} \right)$$

$$R_0 \gg R_2 \gg R_1$$

effective load resistance: $R_0 \left(1 + \frac{R_2}{R_1} \right)$



$$V_- + (I_D - I_-)R_0 = V_T$$

$$V_{out} - V_T = (I_D - I_- + I_1)R_2$$

$$\Rightarrow V_{out} = (I_D - I_- + I_1)R_2 + (I_D - I_-)R_0 + V_-$$

$$= I_D(R_0 + R_2) + I_1 R_2 - I_-(R_0 + R_2) =$$

$$= (I_D - I_-)(R_0 + R_2) + \frac{V_T}{R_1} R_2 =$$

$$V_- + (I_D - I_-)R_0$$

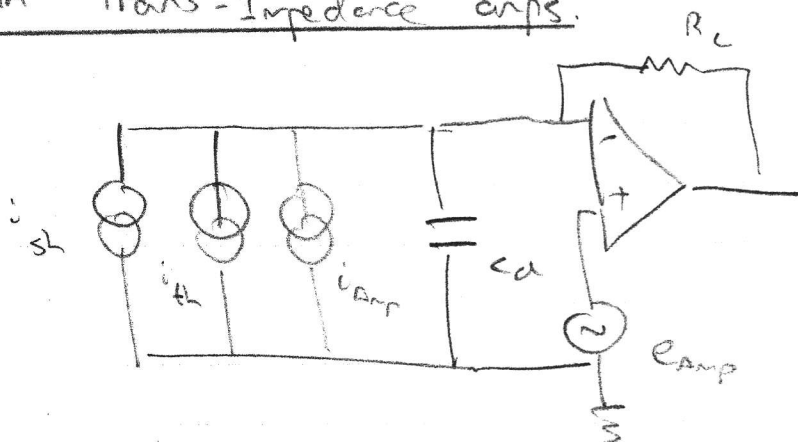
$$= (I_D - I_-)(R_0 + R_2 + R_0 \frac{R_2}{R_1}) + V_- \frac{R_2}{R_1}$$

$$V_- = I_+ R_0$$

$$V_{out \text{ bias}} \approx (I_+ - I_-)R_0 \frac{R_2}{R_1}$$

But with a lower V_- reverse bias voltage

Noise in Trans-Impedance amps.



$$(e_{amp} - v_-) A = v_{out}$$

$$(v_{out} - v_-) = I R_c \quad v_- = I \cdot \frac{1}{i\omega C}$$

$$v_{out} = I R_c + v_- = v_- i\omega R_c C + v_- =$$

$$= v_- (1 + i\omega R_c C)$$

$$\Rightarrow v_- = \frac{v_{out}}{(1 + i\omega R_c C)}$$

$$\left(e_{amp} - \frac{v_{out}}{1 + i\omega R_c C} \right) A = v_{out}$$

$$\Rightarrow A e_{amp} = v_{out} \left(\frac{A}{1 + i\omega R_c C} + 1 \right)$$

$$\Rightarrow V_{out} = e_{amp} \left[\frac{A}{1 + \frac{A}{1 + i\omega RC}} \right]$$

for $\omega > RC$

e_{amp} is amplified, exactly at f_c

freq. all other noise sources start rolling off.

